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Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT Date Submitted: April 16, 2004 (use as many sheets as necessary)				Complete if Known	
				Application Number	Unassigned
				Filing Date	04/16/2004
				First Named Inventor	Geun-Young YEOM
				Group Art Unit	Unassigned
				Examiner Name	Unassigned
				Attorney Docket Number	061887-0120
Sheet	1	of	1		

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
C	A1	2004/0016876	A1	YEOM et al.	01-29-2004	

FOREIGN PATENT DOCUMENTS								
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C	A2	Korean Patent Abstracts (KR), abstract of G.Y. Yeom "Ion Flux Improved Ion Beam Source," Korea 10-2002-0092482 (12/12/2002) abstract only.	A
C	A3	Korean Patent Abstracts (KR), abstract of M.J. Jung et al. "Etch Apparatus Using Neutral Beam," Korea 10-2003-0042958 (06/02/2003) abstract only.	A

Examiner Signature	<div style="font-family: cursive; font-size: 1.2em;">TU HOANG</div>	Date Considered	<div style="font-family: cursive; font-size: 1.2em;">07/05/05</div>
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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